

# POWER OF ATTORNEY OR AUTHORIZATION OF AGENT

Electronic Version v05

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## Title of Invention

Method of Managing Wafer Defects

First Named Applicant :

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Attorney Docket Number :

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I hereby appoint the registered practitioner(s) at Customer Number:

027765



as attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.

I am the Applicant/Inventor.

Full Name of Applicant of Record:

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Signature: /Winston Hsu/

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